

Tuesday 19 February

09:00

3D Sensors 1: Fabrication and characterization Session | Location: EBK Trento "Stringa" Conference Hall Via Sommarive

Session | Location: FBK, Trento, "Stringa" Conference Hall, Via Sommarive, 18 38123 Povo - Trento ITALY |

Convener: Alessandro La Rosa

09:00-09:20 Production of 3D silicon pixel sensors at FBK for the ATLAS IBL

Speaker

Dr Maurizio Boscardin

09:20-09:40 Characterization results of recent CNM 3D productions

Speaker

Andrea Micelli

09:40-10:00

Investigation of the electrical characteristics of double-sided silicon 3D sensors after irradiation with different particles

Speaker

Mr Roberto Mendicino

10:00-10:20 Charge Collection Measurements of Irradiated 3D Sensors

Speaker

Martin Hoeferkamp

10:20-10:40

Characterization of 3D-DDTC strip sensors with passing-through columns

Speaker

Christopher Betancourt

10:40-11:00 Testbeam and laboratory characterization of 3D CMS pixel sensors

Speaker

Prof. Ada Solano

11:00